IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshihide TSUBATA et al.	Art Unit: 2818
Application No.: 10/595,640	THE OTHER ZOTO
Filing or 371(c) Date: May 2, 2006	Examiner: E. TAYLOR
Title: TRANSISTOR AND CVD APPARATUS USED TO DEPOSIT GATE INSULATING FILM THEREOF	

INFORMATION DISCLOSURE STATEMENT COVER LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 CFR § 1.56, Applicant submits references, including references cited in any included Official Communication issued in a corresponding non-U.S. application, with the attached Form PTO/SB/08a.

Where available, Applicant has provided:

- English language equivalents of the foreign language references cited in the included Official Communication or Applicant's Specification and has not provided the foreign language references;
- English language abstracts of the provided foreign language references obtained from a corresponding foreign Patent Office; and
- English machine translations of the provided Japanese references that were prepared by the Intellectual Property Digital Library of the Japanese Patent Office.

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The statement is not a representation that all of the information cited is necessarily effective as prior art against the application.

Respectfully submitted.

Dated: January 23, 2008

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